



PATENT

Atty. Dkt. No. AMAT/5262/CMP/CMP/RKK

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Tsai, et al.

Serial No.: 09/961,134

Confirmation No.: 4110

Filed: September 21, 2001

For: Method and Apparatus For  
Forming Metal Layers

Group Art Unit: 1753

Examiner: Wong, Edna

MAIL STOP Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING  
37 CFR 1.8

I hereby certify that this correspondence is being deposited on August 25, 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

8/25/04  
Date

*[Signature]*  
Signature

Dear Sir:

**RESPONSE TO OFFICE ACTION DATED JUNE 17, 2004**

In response to the Office Action dated June 17, 2004, having a shortened statutory period for response set to expire on September 17, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5262/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 4 of this paper.